

# International **IR** Rectifier

PD - 91860E

## RADIATION HARDENED POWER MOSFET SURFACE MOUNT (SMD-2)

**IRHNA57160**  
100V, N-CHANNEL  
**R5™** TECHNOLOGY

### Product Summary

Part Number	Radiation Level	R <sub>Ds(on)</sub>	I <sub>D</sub>
IRHNA57160	100K Rads (Si)	0.012Ω	75*A
IRHNA53160	300K Rads (Si)	0.012Ω	75*A
IRHNA54160	600K Rads (Si)	0.012Ω	75*A
IRHNA58160	1000K Rads (Si)	0.013Ω	75*A

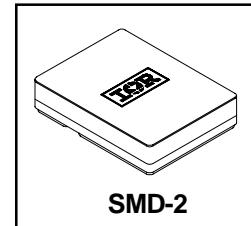
International Rectifier's R5™ technology provides high performance power MOSFETs for space applications. These devices have been characterized for Single Event Effects (SEE) with useful performance up to an LET of 80 (MeV/(mg/cm<sup>2</sup>)). The combination of low R<sub>Ds(on)</sub> and low gate charge reduces the power losses in switching applications such as DC to DC converters and motor control. These devices retain all of the well established advantages of MOSFETs such as voltage control, fast switching, ease of paralleling and temperature stability of electrical parameters.

### Absolute Maximum Ratings

	Parameter		Pre-Irradiation	Units
I <sub>D</sub> @ V <sub>GS</sub> = 12V, T <sub>C</sub> = 25°C	Continuous Drain Current	75*		
I <sub>D</sub> @ V <sub>GS</sub> = 12V, T <sub>C</sub> = 100°C	Continuous Drain Current	69		A
I <sub>DM</sub>	Pulsed Drain Current ①	300		
P <sub>D</sub> @ T <sub>C</sub> = 25°C	Max. Power Dissipation	300		W
	Linear Derating Factor	2.4		W/°C
V <sub>GS</sub>	Gate-to-Source Voltage	±20		V
E <sub>AS</sub>	Single Pulse Avalanche Energy ②	363		mJ
I <sub>AR</sub>	Avalanche Current ①	75		A
E <sub>AR</sub>	Repetitive Avalanche Energy ①	30		mJ
dV/dt	Peak Diode Recovery dV/dt ③	6.0		V/ns
T <sub>J</sub>	Operating Junction	-55 to 150		°C
T <sub>TSG</sub>	Storage Temperature Range			
	Pckg. Mounting Surface Temp.	300 (for 5s)		
	Weight	3.3 (Typical)		g

\* Current is limited by internal wire diameter

For footnotes refer to the last page



### Features:

- Single Event Effect (SEE) Hardened
- Ultra Low R<sub>Ds(on)</sub>
- Low Total Gate Charge
- Proton Tolerant
- Simple Drive Requirements
- Ease of Parallelizing
- Hermetically Sealed
- Surface Mount
- Ceramic Package
- Light Weight

**Electrical Characteristics @  $T_j = 25^\circ\text{C}$  (Unless Otherwise Specified)**

	Parameter	Min	Typ	Max	Units	Test Conditions
BVDSS	Drain-to-Source Breakdown Voltage	100	—	—	V	$V_{GS} = 0\text{V}, I_D = 1.0\text{mA}$
$\Delta BVDSS/\Delta T_J$	Temperature Coefficient of Breakdown Voltage	—	0.115	—	V/ $^\circ\text{C}$	Reference to $25^\circ\text{C}$ , $I_D = 1.0\text{mA}$
$R_{DS(on)}$	Static Drain-to-Source On-State Resistance	—	—	0.013	$\Omega$	$V_{GS} = 12\text{V}, I_D = 75\text{A}$ ④
		—	—	0.012		$V_{GS} = 12\text{V}, I_D = 69\text{A}$
$V_{GS(\text{th})}$	Gate Threshold Voltage	2.0	—	4.0	V	$V_{DS} = V_{GS}, I_D = 1.0\text{mA}$
$g_{fs}$	Forward Transconductance	42	—	—	S ( $\text{mS}$ )	$V_{DS} > 15\text{V}, I_{DS} = 69\text{A}$ ④
$I_{DSS}$	Zero Gate Voltage Drain Current	—	—	10	$\mu\text{A}$	$V_{DS} = 80\text{V}, V_{GS} = 0\text{V}$
		—	—	25		$V_{DS} = 80\text{V}, V_{GS} = 0\text{V}, T_J = 125^\circ\text{C}$
$I_{GSS}$	Gate-to-Source Leakage Forward	—	—	100	$\text{nA}$	$V_{GS} = 20\text{V}$
$I_{GSS}$	Gate-to-Source Leakage Reverse	—	—	-100		$V_{GS} = -20\text{V}$
$Q_g$	Total Gate Charge	—	—	160	$\text{nC}$	$V_{GS} = 12\text{V}, I_D = 75\text{A}$
$Q_{gs}$	Gate-to-Source Charge	—	—	55		$V_{DS} = 50\text{V}$
$Q_{gd}$	Gate-to-Drain ('Miller') Charge	—	—	65		
$t_{d(on)}$	Turn-On Delay Time	—	—	35	$\text{ns}$	$V_{DD} = 50\text{V}, I_D = 75\text{A}, R_G = 2.35\Omega$
$t_r$	Rise Time	—	—	125		
$t_{d(off)}$	Turn-Off Delay Time	—	—	75		
$t_f$	Fall Time	—	—	50		
$L_S + L_D$	Total Inductance	—	4.0	—	nH	Measured from the center of drain pad to center of source pad
$C_{iss}$	Input Capacitance	—	6440	—	$\text{pF}$	$V_{GS} = 0\text{V}, V_{DS} = 25\text{V}$ $f = 1.0\text{MHz}$
$C_{oss}$	Output Capacitance	—	1660	—		
$C_{rss}$	Reverse Transfer Capacitance	—	60	—		

**Source-Drain Diode Ratings and Characteristics**

	Parameter	Min	Typ	Max	Units	Test Conditions
$I_S$	Continuous Source Current (Body Diode)	—	—	75*	A	$T_j = 25^\circ\text{C}, I_S = 75\text{A}, V_{GS} = 0\text{V}$ ④
$I_{SM}$	Pulse Source Current (Body Diode) ①	—	—	300		
$V_{SD}$	Diode Forward Voltage	—	—	1.2	V	$T_j = 25^\circ\text{C}, I_S = 75\text{A}, V_{GS} = 0\text{V}$ ④
$t_{rr}$	Reverse Recovery Time	—	—	300	nS	$T_j = 25^\circ\text{C}, I_F = 35\text{A}, dI/dt \geq 100\text{A}/\mu\text{s}$
$Q_{RR}$	Reverse Recovery Charge	—	—	2.2	$\mu\text{C}$	$V_{DD} \leq 25\text{V}$ ④
$t_{on}$	Forward Turn-On Time	Intrinsic turn-on time is negligible. Turn-on speed is substantially controlled by $L_S + L_D$ .				

\* Current is limited by internal wire diameter

**Thermal Resistance**

	Parameter	Min	Typ	Max	Units	Test Conditions
$R_{thJC}$	Junction-to-Case	—	—	0.42	$^\circ\text{C/W}$	
$R_{thJ-PCB}$	Junction-to-PC board	—	1.6	—		soldered to a 2" square copper-clad board

**Note: Corresponding Spice and Saber models are available on the G&S Website.**

For footnotes refer to the last page

## Radiation Characteristics

IRHNA57160

International Rectifier Radiation Hardened MOSFETs are tested to verify their radiation hardness capability. The hardness assurance program at International Rectifier is comprised of two radiation environments. Every manufacturing lot is tested for total ionizing dose (per notes 5 and 6) using the TO-3 package. Both pre- and post-irradiation performance are tested and specified using the same drive circuitry and test conditions in order to provide a direct comparison.

**Table 1. Electrical Characteristics @  $T_j = 25^\circ\text{C}$ , Post Total Dose Irradiation<sup>⑤⑥</sup>**

	Parameter	Up to 600K Rads(Si) <sup>1</sup>				Units	Test Conditions
		Min	Max	Min	Max		
$\text{BV}_{\text{DSS}}$	Drain-to-Source Breakdown Voltage	100	—	100	—	V	$\text{V}_{\text{GS}} = 0\text{V}, \text{I}_D = 1.0\text{mA}$
$\text{V}_{\text{GS(th)}}$	Gate Threshold Voltage <sup>④</sup>	2.0	4.0	1.5	4.0		$\text{V}_{\text{GS}} = \text{V}_{\text{DS}}, \text{I}_D = 1.0\text{mA}$
$\text{I}_{\text{GSS}}$	Gate-to-Source Leakage Forward	—	100	—	100	nA	$\text{V}_{\text{GS}} = 20\text{V}$
$\text{I}_{\text{GSS}}$	Gate-to-Source Leakage Reverse	—	-100	—	-100		$\text{V}_{\text{GS}} = -20\text{V}$
$\text{I}_{\text{DSS}}$	Zero Gate Voltage Drain Current	—	10	—	10	$\mu\text{A}$	$\text{V}_{\text{DS}}=80\text{V}, \text{V}_{\text{GS}}=0\text{V}$
$\text{R}_{\text{DS(on)}}$	Static Drain-to-Source <sup>④</sup> On-State Resistance (TO-3)	—	0.013	—	0.014	$\Omega$	$\text{V}_{\text{GS}} = 12\text{V}, \text{I}_D = 45\text{A}$
$\text{R}_{\text{DS(on)}}$	Static Drain-to-Source <sup>④</sup> On-State Resistance (SMD-2)	—	0.012	—	0.013	$\Omega$	$\text{V}_{\text{GS}} = 12\text{V}, \text{I}_D = 45\text{A}$
$\text{V}_{\text{SD}}$	Diode Forward Voltage <sup>④</sup>	—	1.2	—	1.2	V	$\text{V}_{\text{GS}} = 0\text{V}, \text{I}_S = 45\text{A}$

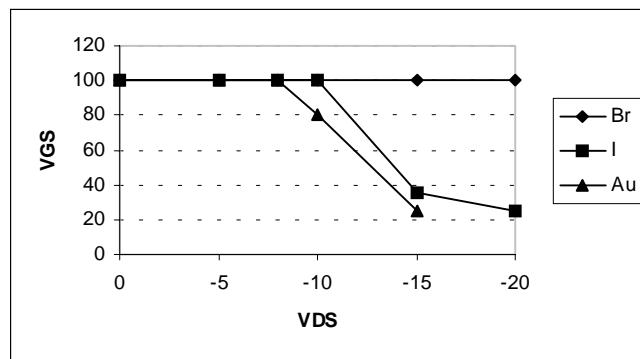
1. Part numbers IRHNA57160, IRHNA53160 and IRHNA54160

2. Part number IRHNA58160

International Rectifier radiation hardened MOSFETs have been characterized in heavy ion environment for Single Event Effects (SEE). Single Event Effects characterization is illustrated in Fig. a and Table 2.

**Table 2. Single Event Effect Safe Operating Area**

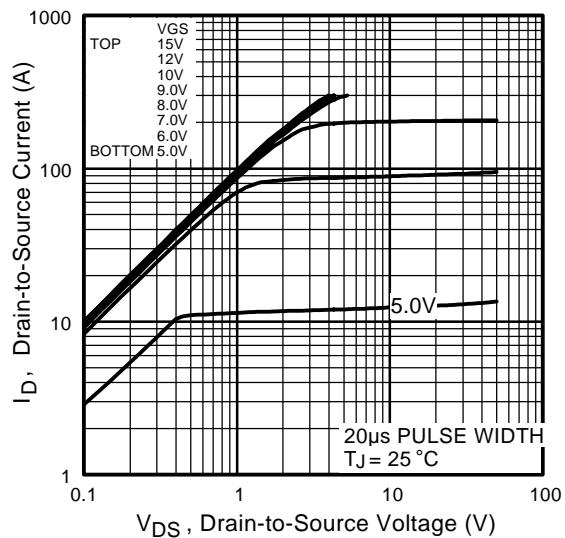
Ion	LET MeV/(mg/cm <sup>2</sup> )	Energy (MeV)	Range (μm)	$\text{V}_{\text{DS}}$ (V)				
				@ $\text{V}_{\text{GS}}=0\text{V}$	@ $\text{V}_{\text{GS}}=-5\text{V}$	@ $\text{V}_{\text{GS}}=-10\text{V}$	@ $\text{V}_{\text{GS}}=-15\text{V}$	@ $\text{V}_{\text{GS}}=-20\text{V}$
Br	36.7	309	39.5	100	100	100	100	100
I	59.8	341	32.5	100	100	100	35	25
Au	82.3	350	28.4	100	100	80	25	—



**Fig a.** Single Event Effect, Safe Operating Area

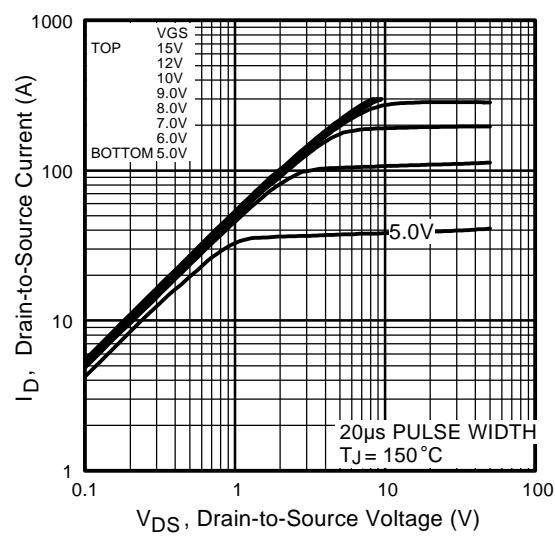
For footnotes refer to the last page

## IRHNA57160

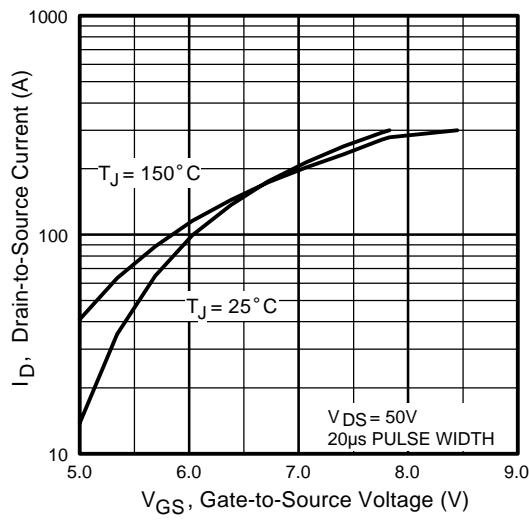


**Fig 1.** Typical Output Characteristics

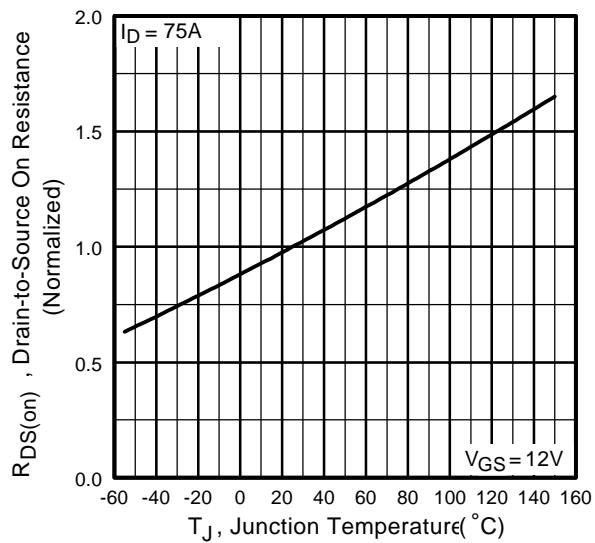
## Pre-Irradiation



**Fig 2.** Typical Output Characteristics



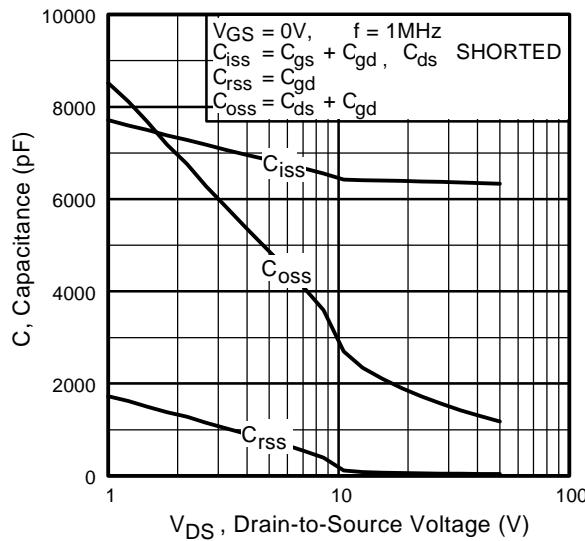
**Fig 3.** Typical Transfer Characteristics



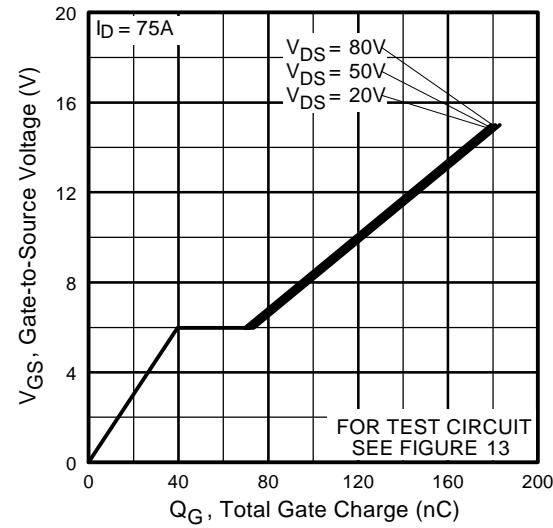
**Fig 4.** Normalized On-Resistance Vs. Temperature

## Pre-Irradiation

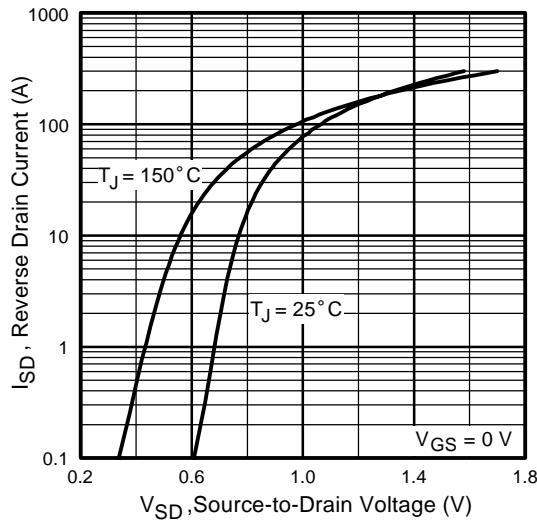
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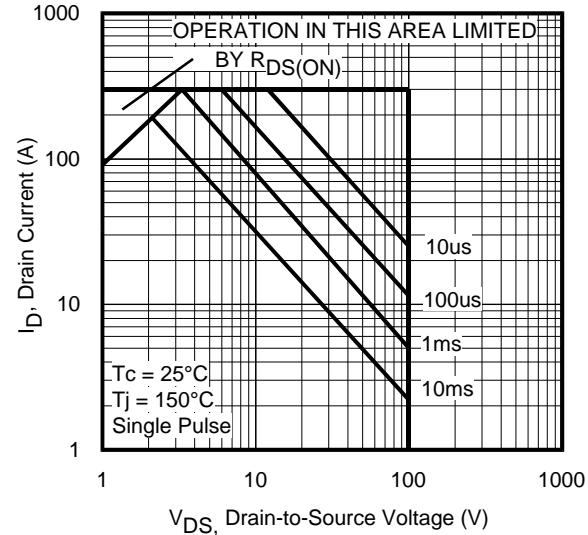
**Fig 5.** Typical Capacitance Vs.  
Drain-to-Source Voltage



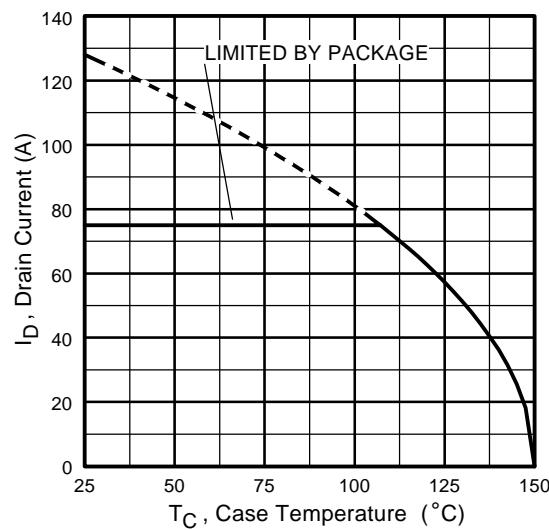
**Fig 6.** Typical Gate Charge Vs.  
Gate-to-Source Voltage



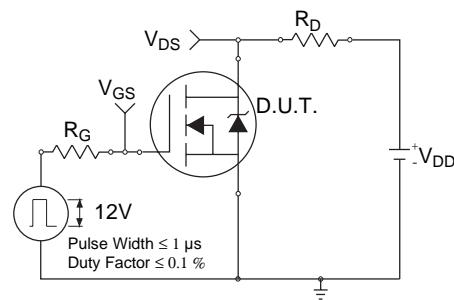
**Fig 7.** Typical Source-Drain Diode  
Forward Voltage



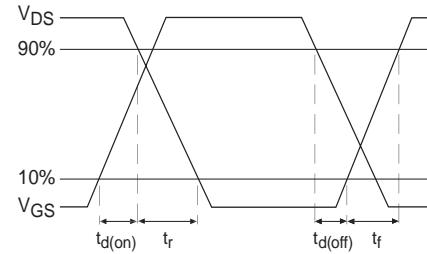
**Fig 8.** Maximum Safe Operating Area



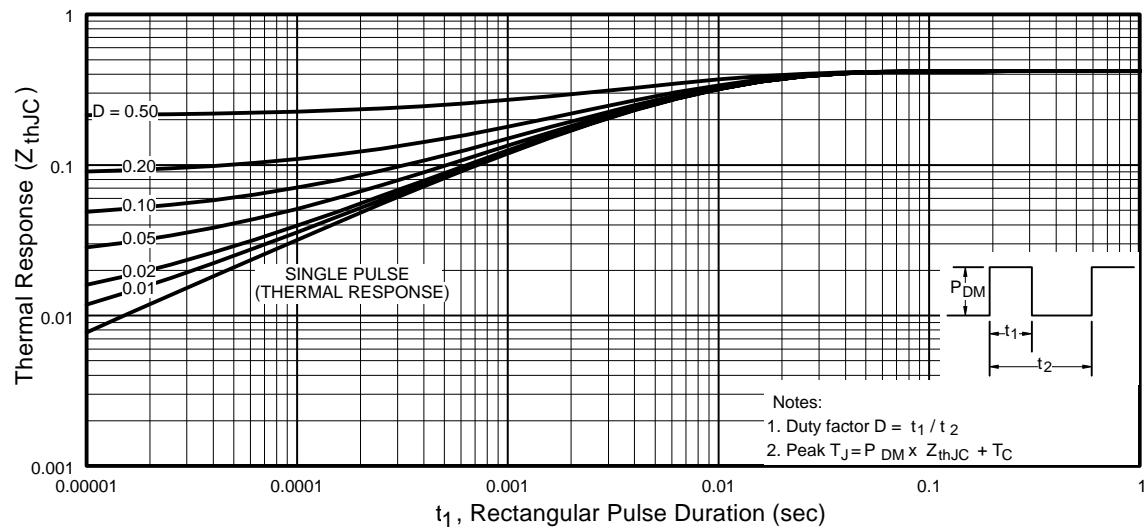
**Fig 9.** Maximum Drain Current Vs.  
Case Temperature



**Fig 10a.** Switching Time Test Circuit



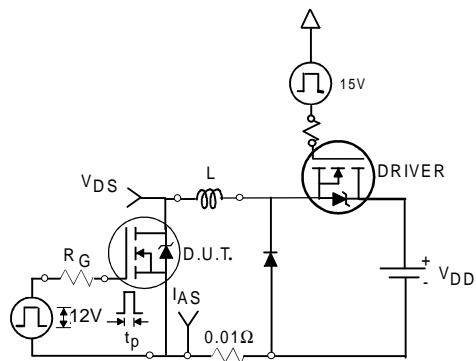
**Fig 10b.** Switching Time Waveforms



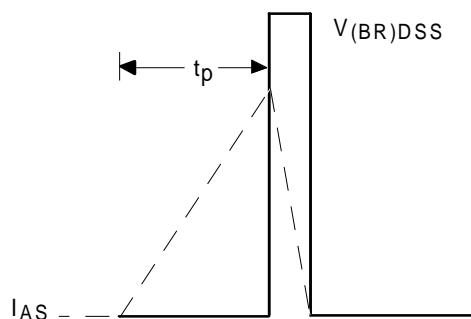
**Fig 11.** Maximum Effective Transient Thermal Impedance, Junction-to-Case

## Pre-Irradiation

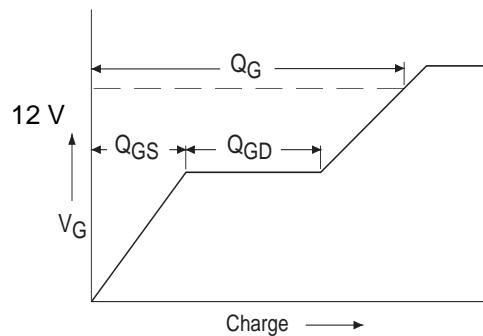
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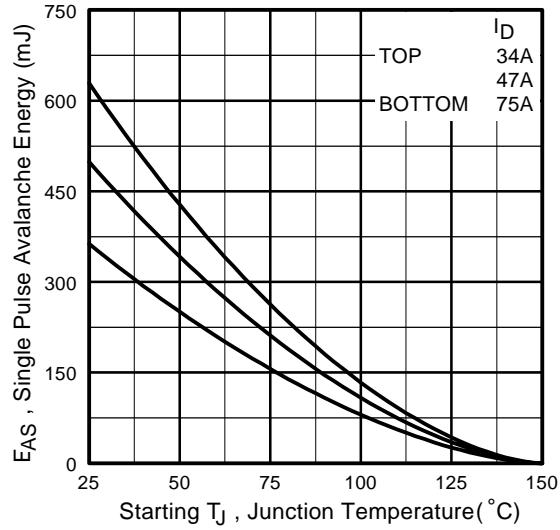
**Fig 12a.** Unclamped Inductive Test Circuit



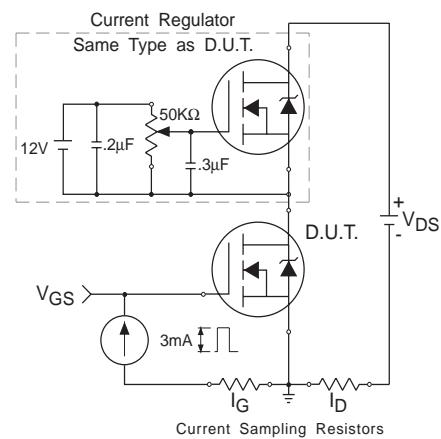
**Fig 12b.** Unclamped Inductive Waveforms



**Fig 13a.** Basic Gate Charge Waveform



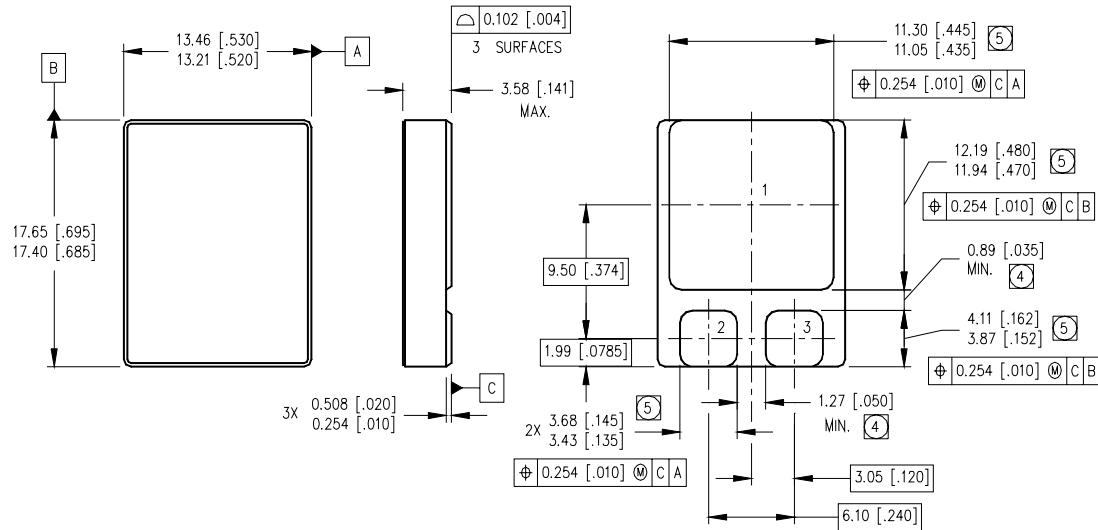
**Fig 12c.** Maximum Avalanche Energy Vs. Drain Current



**Fig 13b.** Gate Charge Test Circuit

**Footnotes:**

- ① Repetitive Rating; Pulse width limited by maximum junction temperature.
- ② V<sub>DD</sub> = 50V, starting T<sub>J</sub> = 25°C, L = 0.13 mH  
Peak I<sub>L</sub> = 75A, V<sub>GS</sub> = 12V
- ③ ISD ≤ 75A, di/dt ≤ 340A/μs,  
V<sub>DD</sub> ≤ 100V, T<sub>J</sub> ≤ 150°C
- ④ Pulse width ≤ 300 μs; Duty Cycle ≤ 2%
- ⑤ **Total Dose Irradiation with V<sub>GS</sub> Bias.**  
12 volt V<sub>GS</sub> applied and V<sub>DS</sub> = 0 during irradiation per MIL-STD-750, method 1019, condition A.
- ⑥ **Total Dose Irradiation with V<sub>DS</sub> Bias.**  
80 volt V<sub>DS</sub> applied and V<sub>GS</sub> = 0 during irradiation per MIL-STD-750, method 1019, condition A.

**Case Outline and Dimensions — SMD-2****NOTES:**

1. DIMENSIONING & TOLERANCING PER ANSI Y14.5M-1982
2. CONTROLLING DIMENSION: INCH.
3. DIMENSIONS ARE SHOWN IN MILLIMETERS (INCHES).
- 4 DIMENSION INCLUDES METALLIZATION FLASH.
- 5 DIMENSION DOES NOT INCLUDE METALLIZATION FLASH.

**PAD ASSIGNMENTS**

- 1 = DRAIN  
2 = GATE  
3 = SOURCE

International  
**IR** Rectifier

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**IR CANADA:** 15 Lincoln Court, Brampton, Ontario L6T3Z2, Tel: (905) 453 2200  
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*Data and specifications subject to change without notice. 3/00*